

1 Reference material

	C_{OX} (fF/ μm^2)	C_O (fF/ μm)	C_j (fF/ μm^2)	m_j	ϕ_b (V)	C_{jsw} (fF/ μm)	m_{jsw}	ϕ_{bsw} (V)
NMOS	6	0.31	2	0.5	0.9	0.28	0.44	0.9
PMOS	6	0.27	1.9	0.48	0.9	0.22	0.32	0.9

MODELS FOR CMOS DEVICES

CMOS (0.25 μm) – Unified Model.

	V_{T0} (V)	γ ($\text{V}^{0.5}$)	V_{DSAT} (V)	k' (A/V^2)	λ (V^{-1})
NMOS	0.43	0.4	0.63	115×10^{-6}	0.06
PMOS	-0.4	-0.4	-1	-30×10^{-6}	-0.1

CMOS (0.25 μm) – Switch Model (R_{eq})

V_{DD} (V)	1	1.5	2	2.5
NMOS (k Ω)	35	19	15	13
PMOS (k Ω)	115	55	38	31

CMOS (0.25 μm) – BSIM Model

See Website: <http://bwrc.eecs.berkeley.edu/IcBook>

Name	Value
kT/q	25.875 mJ/C
NMOSFET I_S	21.0 pA
PMOSFET I_S	41.8 pA
n (for I_D calculation)	1.5

VALUES OF MATERIAL AND PHYSICAL CONSTANTS

Name	Symbol	Value	Units
Room temperature	T	300 (= 27°C)	K
Boltzman constant	k	1.38×10^{-23}	J/K
Electron charge	q	1.6×10^{-19}	C
Thermal voltage	$\phi_T = kT/q$	26	mV (at 300 K)
Intrinsic Carrier Concentration (Silicon)	n_i	1.5×10^{10}	cm^{-3} (at 300 K)
Permittivity of Si	ϵ_{Si}	1.05×10^{-12}	F/cm
Permittivity of SiO ₂	ϵ_{SiO_2}	3.5×10^{-13}	F/cm
Resistivity of Al	ρ_{Al}	2.7×10^{-8}	$\Omega\text{-m}$
Resistivity of Cu	ρ_{Cu}	1.7×10^{-8}	$\Omega\text{-m}$
Magnetic permeability of vacuum (similar for SiO ₂)	μ_0	12.6×10^{-7}	Wb/Am
Speed of light (in vacuum)	c_0	30	cm/nsec
Speed of light (in SiO ₂)	c_{SiO_2}	15	cm/nsec

$$P = P_{\text{SWITCH}} + P_{\text{SHORT}} + P_{\text{LEAK}}$$

$$P_{\text{SWITCH}} = C \cdot V_{DD}^2 \cdot f \cdot A$$

$$\dagger P_{\text{SHORT}} = \frac{b}{12} (V_{DD} - 2 \cdot V_T)^3 \cdot f \cdot A \cdot t$$

$$P_{\text{LEAK}} = V_{DD} \cdot (I_{\text{SUB}} + I_{\text{GATE}} + I_{\text{JUNCTION}} + I_{\text{GIDL}})$$

C : total switched capacitance

V_{DD} : high voltage

f : switching frequency

A : switching activity

b : MOS transistor gain

V_T : threshold voltage

t : rise/fall time of inputs

$\dagger P_{\text{SHORT}}$ usually $\leq 10\%$ of P_{SWITCH}

Smaller as $V_{DD} \rightarrow V_T$

$A < 0.5$ for combinational nodes, 1 for clocked nodes.

FORMULAS AND EQUATIONS

Diode

$$I_D = I_S(e^{V_D/\phi_T} - 1) = Q_D/\tau_T$$

$$C_j = \frac{C_{j0}}{(1 - V_D/\phi_0)^m}$$

$$K_{eq} = \frac{-\phi_0^m}{(V_{high} - V_{low})(1 - m)} \times \frac{1}{[(\phi_0 - V_{high})^{1-m} - (\phi_0 - V_{low})^{1-m}]}$$

MOS Transistor

$$V_T = V_{T0} + \gamma(\sqrt{|-2\phi_F + V_{SB}|} - \sqrt{|-2\phi_F|})$$

$$I_D = \frac{k_n W}{2 L} (V_{GS} - V_T)^2 (1 + \lambda V_{DS}) \text{ (sat)}$$

$$I_D = v_{sat} C_{ox} W \left(V_{GS} - V_T - \frac{V_{DSAT}}{2} \right) (1 + \lambda V_{DS}) \text{ (velocity sat)}$$

$$I_D = k_n \frac{W}{L} (V_{GS} - V_T) V_{DS} - \frac{V_{DS}^2}{2} \text{ (triode)}$$

$$I_D = I_S e^{\frac{V_{GS}}{n k T / q}} \left(1 - e^{-\frac{V_{DS}}{k T / q}} \right) \text{ (subthreshold)}$$

Deep Submicron MOS Unified Model

$$I_D = 0 \text{ for } V_{GT} \leq 0$$

$$I_D = k' \frac{W}{L} \left(V_{GT} V_{min} - \frac{V_{min}^2}{2} \right) (1 + \lambda V_{DS}) \text{ for } V_{GT} \geq 0$$

$$\text{with } V_{min} = \min(V_{GT}, V_{DS}, V_{DSAT})$$

$$\text{and } V_{GT} = V_{GS} - V_T$$

MOS Switch Model

$$R_{eq} = \frac{1}{2} \left(\frac{V_{DD}}{I_{DSAT}(1 + \lambda V_{DD})} + \frac{V_{DD}/2}{I_{DSAT}(1 + \lambda V_{DD}/2)} \right) \approx \frac{3}{4} \frac{V_{DD}}{I_{DSAT}} \left(1 - \frac{5}{6} \lambda V_{DD} \right)$$

Inverter

$$V_{OH} = f(V_{OL})$$

$$V_{OL} = f(V_{OH})$$

$$V_M = f(V_M)$$

$$t_p = 0.69 R_{eq} C_L = \frac{C_L (V_{swing}/2)}{I_{avg}}$$

$$P_{dyn} = C_L V_{DD} V_{swing} f$$

$$P_{stat} = V_{DD} I_{DD}$$

Static CMOS Inverter

$$V_{OH} = V_{DD}$$

$$V_{OL} = GND$$

$$V_M \approx \frac{r V_{DD}}{1 + r} \text{ with } r = \frac{k_p V_{DSATp}}{k_n V_{DSATn}}$$

$$V_{IH} = V_M - \frac{V_M}{g} \quad V_{IL} = V_M + \frac{V_{DD} - V_M}{g}$$

$$\text{with } g \approx \frac{1 + r}{(V_M - V_{Tn} - V_{DSATn}/2)(\lambda_n - \lambda_p)}$$

$$t_p = \frac{t_{pHL} + t_{pLH}}{2} = 0.69 C_L \left(\frac{R_{eqn} + R_{eqp}}{2} \right)$$

$$P_{av} = C_L V_{DD}^2 f$$

Interconnect

$$\text{Lumped RC: } t_p = 0.69 RC$$

$$\text{Distributed RC: } t_p = 0.38 RC$$

RC-chain:

$$\tau_N = \sum_{i=1}^N R_i \sum_{j=i}^N C_j = \sum_{i=1}^N C_i \sum_{j=1}^i R_j$$

Transmission line reflection:

$$\rho = \frac{V_{refl}}{V_{inc}} = \frac{I_{refl}}{I_{inc}} = \frac{R - Z_0}{R + Z_0}$$

CMOS COMBINATIONAL LOGIC

Transistor Sizing using Logical Effort

$$F = \frac{C_L}{C_{g1}} = \prod_{i=1}^N \frac{f_i}{b_i} \quad G = \prod_{i=1}^N g_i \quad D = t_{p0} \sum_{j=1}^N \left(p_j + \frac{f_j g_j}{\gamma} \right)$$

$$B = \prod_{i=1}^N b_i \quad H = FGB \quad D_{min} = t_{p0} \left(\sum_{j=1}^N p_j + \frac{N(N/H)}{\gamma} \right)$$